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2812/a
1-31-03
L. Spruell

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph Wasshuber, et al.

Docket No: TI-31016

Serial No: 10/020,111

Conf. No: 5837

Examiner: Richard A. Booth

Art Unit: 2812

Filed: 12/14/2001

For: METHODS AND APPARATUS FOR INDUCING STRESS IN A SEMICONDUCTOR
DEVICE

for OK

AMENDMENT UNDER 37 C.F.R. § 1.111

Assistant Commissioner For Patents
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)
I hereby certify that the above correspondence is being
deposited with the U.S. Postal Service with sufficient postage
as First Class Mail in an envelope addressed to: Assistant
Commissioner for Patents, Washington, DC 20231 on
1-21-03.

Ann Trent
Ann Trent

Dear Sir:

Responsive to the Office Action mailed October 24, 2002, in connection with the
above identified application, Applicants respectfully submit the following amendments
and remarks.

02/03/2003 LSPRUELL 00000004 200668 10020111
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JAN 28 2003
TECHNOLOGY CENTER 2800